

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Hongyong Zhang	Art Unit :	2814
Serial No. :	09/362,808	Examiner :	Shrinivas H. Rao
Filed :	July 28, 1999	Conf. No. :	7320
Title :	METHOD OF FABRICATING SEMICONDUCTOR DEVICE		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION TO WITHDRAW

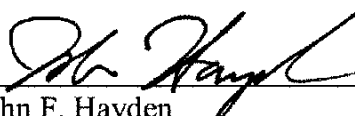
Applicant hereby petitions under §1.313(c)(2) for the withdrawal of this application from issue to permit consideration of an Information Disclosure Statement. The issue fee was paid on December 29, 2009.

A request for continued examination of this application under §1.114 is being filed simultaneously herewith. The request for continued examination is intended to continue this application on the grant of this petition.

A fee in the amount of \$130 in payment of the petition fee required by 1.17(h) is being paid concurrently herewith on the electronic filing system (EFS) by way of deposit account authorization. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: March 4, 2010



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